ocket No.: 146712001800

This Listing of Claims will replace all prior versions, and listings, of claims in the application:

LISTING OF CLAIMS

1. (Currently Amended) A recording device for perpendicular recording comprising a magnetic head and a recording medium,

the recording medium comprising a substrate and a magnetic underlayer on the substrate,

the underlayer comprising an easy axis of magnetization directed in a direction substantially transverse to a traveling direction of the magnetic head, wherein the underlayer has the easy axis of magnetization induced by a magnetron field.

- 2. (Original) The recording device of claim 1, wherein the underlayer comprises a substantially radial or transverse anisotropy.
- 3. (Original) The recording device of claim 1, wherein the underlayer comprises a soft magnetic material.
- 4. (Original) The recording device of claim 1, wherein the underlayer provides a return path for a recording head.
- 5. (Original) The recording device of claim 4, wherein the underlayer amplifies a perpendicular component of a write field in a recording layer overlying the underlayer.
- 6. (Original) The recording device of claim 1, wherein the underlayer has low magnetostriction.

2

va-54973

bcket No.: 146712001800

7. (Original) The recording device of claim 1, wherein the underlayer comprises a material selected from the group consisting of a permalloy, a CoZrNb alloy, a NiFe alloy and a FeAIN alloy.

3

8. (Original) The recording device of claim 1, wherein the recording medium is selected from the group consisting of a disk and a tape.

9. (Canceled)

- 10. (Original) The recording device of claim 1, wherein a thickness of the soft magnetic underlayer is about 200-400 nm.
- 11. (Withdrawn) A method for manufacturing a magnetic recording disk for perpendicular recording, comprising:

applying a magnetron field and

depositing an underlayer on a substrate,

wherein the underlayer comprises an easy axis of magnetization directed in a radial direction of the magnetic recording disk.

12. (Withdrawn) The method of claim 11, further comprising heating the substrate.

3

va-54973

bcket No.: 146712001800

13. (Withdrawn) The method of claim 11, wherein the depositing an underlayer is by sputtering.

- 14. (Withdrawn) The method of claim 13, wherein the sputtering is a reactive sputtering.
- 15. (Withdrawn) The method of claim 11, wherein the substrate is kept stationary during said depositing a magnetic underlayer.
- 16. (Withdrawn) The method of claim 15, wherein a diameter of a magnetron source producing the magnetron field is larger than a diameter of the substrate.
- 17. (Withdrawn) The method of claim 11, wherein the substrate is rotated during said depositing a magnetic underlayer.
- 18. (Withdrawn) The method of claim 17, wherein a size of a magnetron source producing the magnetron field is smaller or comparable to a diameter of the substrate.
- 19. (Withdrawn) The method of claim 18, wherein the substrate is placed off-center with respect to the magnetron source.
- 20. (Currently Amended) A magnetic recording disk for perpendicular recording, comprising a substrate and means for providing a return path for a recording head, wherein the

va-54973 4

ocket No.: 146712001800

means comprises an underlayer that has the easy axis of magnetization induced by a magnetron field.

21. (Currently Amended) A disk drive comprising a magnetic recording disk for perpendicular recording, wherein the magnetic recording disk comprises a substrate and a magnetic underlayer on the substrate, wherein the underlayer comprises an easy axis of magnetization directed in a radial direction of the magnetic recording disk, wherein the underlayer has the easy axis of magnetization induced by a magnetron field.

va-54973

5